



Docket No.: 0756-7204

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of )

Koichiro TANAKA )

Serial No. 10/671,539 )

Group Art Unit: 2828

Filed: September 29, 2003 )

Examiner: Minsun Harvey

For: LASER IRRADIATION APPARATUS AND )

METHOD OF MANUFACTURING )

SEMICONDUCTOR DEVICE

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with  
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P. O. Box 1450, Alexandria VA 22313-1450, on 7-11

*[Signature]*

**SECOND REQUEST FOR STATUS**

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

*[Signature]*

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